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**OLIFF & BERRIDGE, PLC**

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ATTORNEYS AT LAW

**Application Data Sheet****Application Information**

Application Type:: Regular  
Subject Matter:: Utility  
CD-ROM or CD-R:: None  
Title:: METHOD FOR PRODUCING SOI WAFER AND SOI WAFER  
Attorney Docket Number:: 118749  
Total Drawing Sheets:: 4  
Small Entity:: No

**Applicant Information**

Applicant Authority type:: Inventor  
Primary Citizenship Country:: Japan  
Status:: Full Capacity  
Given Name:: Isao  
Family Name:: YOKOKAWA  
City of Residence:: Gunma  
Country of Residence:: Japan

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Applicant Authority type:: Inventor  
Primary Citizenship Country:: Japan  
Status:: Full Capacity  
Given Name:: Kiyoshi  
Family Name:: MITANI  
City of Residence:: Gunma  
Country of Residence:: Japan

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**Correspondence Information**

Correspondence Customer Number:: 25944

<b>Foreign Priority Information</b>			
Country::	Application Number::	Filing Date::	Priority Claimed::
Japan	2003-049415	02/26/2003	Yes
<b>Assignee Information</b>			
Assignee Name::	SHIN-ETSU HANDOTAI CO., LTD.		
Street of mailing address::	4-2, Marunouchi 1-chome,		
City of mailing address::	Chiyoda-ku		
State or Province of mailing address::	Tokyo		
Country of mailing address::	Japan		